S	earch	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/774,384	UCHIYAMA, TATSUHIKO	
Examiner	Art Unit	
Lori L. Coletta	3612	

	SEARCHED		
Class	Subclass	Date	Examiner
296	193.03 193.09 193.11 203.02	6/14/2005	LLC

INI	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
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(	(INCLUDING SEARCH STRATEGY)		
	DATE	EXMR	
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